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PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10092456	FILING DATE 03/06/2002	CLASS 365	SUBCLASS	GAU 2818	EXAMINER
**APPLICANTS: Hwang Jeng; Jin Guangxiang; Chen Xiaoyi;					
**CONTINUING DATA VERIFIED:					
** FOREIGN APPLICATIONS VERIFIED:					
PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>		ATTORNEY DOCKET NO	
Foreign priority claimed 35 USC 119 conditions met		<input type="checkbox"/> yes <input type="checkbox"/> no - yes <input type="checkbox"/> no		AMAT/6437/ETCH/METAL/JB	
Verified and Acknowledged Examiner's initials					
TITLE : Etching methods for a magnetic memory cell stack					
U.S. DEPT. OF COMM./PAT & TM-PTO-436 (Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.	Print Fig.
TERMINAL DISCLAIMER		Primary Examiner		
		Application Examiner		
PREPARED FOR ISSUE				
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